



ELECTRONIC COPY

LG766667322
Report verification at igi.org



January 20, 2026

IGI Report Number **LG766667322**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.16 X 7.08 X 4.47 MM**

GRADING RESULTS

Carat Weight **1.99 CARAT**

Color Grade **G**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

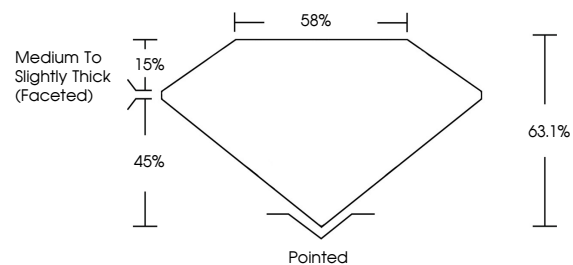
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG766667322**

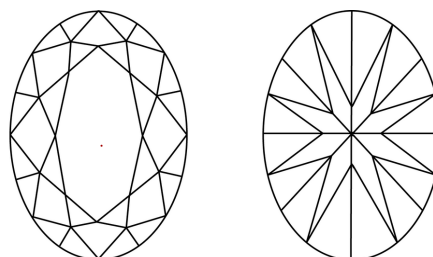
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

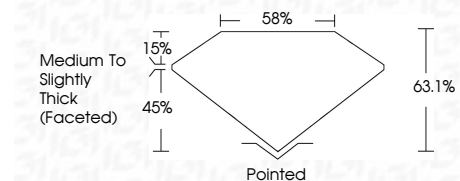
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



January 20, 2026
IGI Report No LG766667322
OVAL BRILLIANT
10.16 X 7.08 X 4.47 MM
1.99 CARAT
Color Grade G
Clarity Grade VVS 2
Depth 63.1%
Table 58%
Girdle Medium to Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG766667322

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